Application/Control No. Applicant(s)/Patent Under Reexamination 10/695,874 HAYAMI ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 1765 Kin-Chan Chen **U.S. PATENT DOCUMENTS** Date **Document Number** Name Classification Country Code-Number-Kind Code MM-YYYY US-6,677,194 01-2004 Yamanaka et al. 438/199 Α 438/303 В US-6,897,118 05-2005 Poon et al. 03-2005 Odake et al. 438/264 С US-6,872,624 11-2002 Ling et al. 438/265 US-6,479,350 D 07-2001 Chen, Tung-Po 438/199 Ε US-6,255,152 F US-6,083,780 07-2000 Yasuda, Hiroyasu 438/162. US-5,830,788 11-1998 Hiroki et al. 438/199 G US-5,770,494 06-1998 Yamamoto et al. 438/232 Н US-6,031,268 02-2000 Hiroki et al. 257/345 1 US-J Κ US-US-L US-М FOREIGN PATENT DOCUMENTS Date **Document Number** Name Classification Country Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S T **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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